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## BIB DATA SHEET

CONFIRMATION NO. 7948

SERIAL NUMBER	FILING or 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO. MOXT-002-US	
10/525,611	09/12/2005	427	2812		
<b>APPLICANTS</b> Henry W. White, Columbia, MO; [AR/] Yungryel Ryu, Columbia, MO; Tae-seok Lee, Naperville, IL;					
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/US03/27143 08/27/2003 [Yes.] [AR/] which claims benefit of 60/406,500 08/28/2002					
<b>** FOREIGN APPLICATIONS *****</b> [None.] [AR/]					
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> [ ] SMALL ENTITY **					
Foreign Priority claimed <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and /ANGEL ROMAN/ Acknowledged Examiner's signature	<input type="checkbox"/> Met after Allowance [Initials]	<b>STATE OR COUNTRY</b> MO	<b>SHEETS DRAWINGS</b> 20	<b>TOTAL CLAIMS</b> 117	<b>INDEPENDENT CLAIMS</b> 5
<b>ADDRESS</b> JACOBS & KIM LLP 1050 WINTER STREET SUITE 1000, #1082 WALTHAM, MA 02451-1401 UNITED STATES					
<b>TITLE</b> Hybrid beam deposition system and methods for fabricating metal oxide-zno films, p-type zno films, and zno-based II-VI compound semiconductor devices					
<b>FILING FEE RECEIVED</b> 3140	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		